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Contents

- vii Authors
- ix Symposium Committees
- xiii Conference Committee

SESSION 1 VIRTUAL REALITY AND 3D DISPLAY

- 10817 03 Fast stereo matching using image pyramid for lunar rover [10817-7]
- 10817 04 **Tunable liquid lens equipped virtual reality adapter for scientific, medical, and therapeutic** goals [10817-8]
- 10817 05 Depth-aware interactive display method for vision-tangible mixed reality [10817-9]

SESSION 2 DEPTH AND LIGHT FIELD

- 10817 06 Innovative hole-filling method for depth-image-based rendering (DIBR) based on context learning (Invited Paper) [10817-1]
- 10817 07 Curvature feature extraction based ICP points cloud registration method [10817-3]
- 10817 08 Influence of textures on the robustness of the depth estimation algorithm for light field [10817-4]

SESSION 3 COMPUTATIONAL ACQUISITION AND ANALYSIS I

- 10817 09Superresolution imaging through scattering media by spectrum correlation (Invited Paper)
[10817-10]
- 10817 0A Monocular vision avoidance method based on fully convolutional networks [10817-12]
- 10817 OB A denoising method of medical ultrasound image based on guided image filtering and fractional derivative [10817-13]
- 10817 OC Programmable compressed sensing using simple deterministic sensing matrices [10817-14]
- 10817 0D Infrared and visible light image registration algorithm based on clustering and mutual information [10817-15]

SESSION 4 COMPUTATIONAL ACQUISITION AND ANALYSIS II

- 10817 OE Novel 3D mesh quality assessment method based on curvature analysis (Invited Paper) [10817-16]
- 10817 OF Color characterization for displays based on color appearance matching [10817-17]
- 10817 0G Moving target detection based on edge optical flow from satellite videos [10817-18]
- 10817 0H Transform coefficients distribution of the future versatile video coding (VVC) standard [10817-19]

SESSION 5 COMPUTATIONAL OPTICS

- 10817 0JThe new-type silicon photomultiplier for ToF LiDAR and other pulse detecting applications
[10817-21]
- 10817 OL Optimization algorithms for wavefront sensorless adaptive optics [10817-23]

POSTER SESSION

10817 OM Self-augmented deep generative network for blind image deblurring [10817-11] 10817 ON Color clustering for ocean surface over Chinese surrounding sea areas based on octree color quantization [10817-24] 10817 OR Iterative optimization procedure based design of phase masks suitable for computational depth of field extension [10817-28] A super-resolution imaging system based on sub-pixel camera shifting [10817-29] 10817 OS 10817 OT An optical flow network for enhancing the edge information [10817-30] 10817 OU Image super-resolution reconstruction based on residual dictionary learning by support vector **regression** [10817-31] 10817 OV A scale adaptive tracker based on point feature [10817-32] 10817 OX A structural decomposition-based method for restoring images corrupted by impulse noise [10817-34] 10817 OY Free-view walkthrough for the light field display [10817-35] 10817 OZ High-efficiency generating of photorealistic super-multiview image for glasses-free three-

dimensional display based on distributed rendering [10817-36]

- 10817 10 The enhancement of depth estimation based on multi-scale convolution kernels [10817-37]
- 10817 13 A parallel matching algorithm for archaeological fragment object designs based on Hausdorff distance [10817-40]
- 10817 15 Effects of rescaling bilinear interpolant on image interpolation quality [10817-42]
- 1081716 Luminance regionalization-based saliency detection for high dynamic range image [10817-43]
- 10817 17 New quality assessment method for dense light fields [10817-44]
- 10817 18 **Comparison of restoration methods for turbulence-degraded images** [10817-45]
- 10817 19 High-level semantic information extraction of remote-sensing images based on deep-learning image classification [10817-46]
- 10817 1A Streak tube imaging system based on compressive sensing [10817-47]
- 10817 1C A novel adaptive Gaussian-weighted mean filter for removal of high-density salt-and-pepper noise from images [10817-49]
- 10817 1D No-reference video quality assessment based on perceptual features extracted from multi-directional video spatiotemporal slices images [10817-50]
- 10817 1E Aliasing artefact index for image interpolation quality assessment [10817-51]
- 10817 1F Extrapolation for image interpolation [10817-52]
- 10817 1G **Remote sensing image classification method based on active-learning deep neural network** [10817-53]
- 10817 1H Spectrum restoration methods of a polarimetric-spectro imager based on light field architecture [10817-54]
- 10817 11 The properties of opaque Csl photocathode [10817-55]

Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Bai, Xueqiong, OF, ON Berzinsh, Janis, 04 Bogdanov, Sergey V., OJ Cao, Jingya, 1A Chang, Ming, 0A Chen, Duo, 06, 0T, 0Y, 10 Chen, Huasong, OX Chen, Liang, 03, 0G Chen, Xiaodong, 07, 0B Chen, Zaiging, 0D Chen, Zhihong, 0U, 0V Cheng, Feiyan, 0D Cheng, Haobo, OF, ON Cheng, Mengzhe, 19 Choi, Gwan Seong, 0C Dai, Qionghai, 09 Deng, Chenyang, OF, ON Deng, Weixin, OB Dong, Liquan, OA Dona, Wenbo, 19 Du, Zhenhua, OD Fan, Xuewu, OR Fan, Yuanyuan, OX Feng, Qiansheng, OX Guo, Jie, 05 Gupta, Pravir Singh, OC Han, Shaokun, 1A Hao, Qun, 08 Hu, Yao, 08 Hua, Heng, OY, 10 Huang, Xiaoqiao, OD Huang, Zhijiao, 17 Hui, Mei, OA Jansone, Zane, 04 Ji, Jiarui, OB Jiang, Gangyi, 0E, 16, 17 Jiang, Hao, 17 Jiang, Zhiguo, OM Jin, Xin, 09 Ke, Jun, OS Kolobov, Nikolay A., OJ Kong, Linggin, OA Levin, Evgeny V., 0J Li, Chao, 06 Li, Feng, 03, 0G Li, Haichao, 03, 0G Li, Jinafei, OU, OV Li, Yang, OH Li, Yasheng, OF, ON

Li, Yue, 05 Liang, Haitao, 07 Liao, Ningfang, OF, ON Lin, Yaoyao, OE Liu, Congyang, 1C Liu, Fei, 1A Liu, Gangping, 0S Liu, Jiawei, OX Liu, Jun, OU Liu, Ming, 0A Liu, Yilin, 07 Liu, Yong-an, 11 Liu, Yucong, 1C Liu, Yue, 05 Liu, Yujian, 1H Liu, Zhe, 11 Maraev, Anton A., 18 Mou, Xuangin, OH, 1D Ozolinsh, Maris, 04 Pastare, Anna, 04 Paulins, Paulis, 04 Peng, Ke, 0M Peng, Shuo, 08 Peng, Weiwei, 0Z Pozdnyakov, Yury I., OJ Rukundo, Olivier, 15, 1E, 1F Sang, Xinzhu, 06, 0T, 0Y, 0Z, 10 Schmidt, Samuel E., 15, 1E, 1F Shao, Hua, 0E, 16 Sheng, Li-zhi, 11 Shi, Junsheng, 0D Shpakovskiy, Timofey V., OJ Shubin, Vitaly E., OJ Shushakov, Dmitry A., 0J Sitarsky, Konstantin Yu., OJ Song, Yang, 0E, 16, 17 Su, Lijuan, 1H Su, Xiu, 07 Sun, Hao, OU, OV Sun, Wanqi, OT, 10 Tian, Jin-shou, 11 Tian, Xiyu, OY, 10 Torgovnikov, Rostislav A., OJ Wang, Huachun, OT Wang, Peng, OT, OY, 10 Wang, Yi, 07, 0B Wang, Yongtian, 05 Wang, Zhenyu, 19 Wang, Zhouping, 09

Wei, Ru-yi, 11 Weng, Dongdong, 05 Wu, Rongteng, 13 Wu, Xueting, OL Xia, Jingjing, OR Xiao, Wen, 1G Xiao, Yuze, OB Xing, Shujun, OZ Xu, Haiyong, 17 Xu, Huaiyuan, 07 Xu, Kuan, 1G Xu, Yong, OB Xu, Zhenheng, OL Yan, Peng, 1D Yang, Jin, OB Yang, Junli, 19 Yang, Tingxiang, 18 Yang, Wenming, OF, ON Yang, Xiaoping, OU, OV Yu, Mei, 0E, 16, 17 Yu, Mengxi, 19 Yuan, Xiuhua, OL Yuan, Yan, 1H Yun, Lijun, OD Zhai, Yu, 1A Zhang, Di, 06 Zhang, Haopeng, OM Zhang, Junjun, 16 Zhang, Libao, 1C Zhang, Ling, OR Zhang, Linxia, OS Zhang, Zhenliang, 05 Zhao, Bao-sheng, 11 Zhao, Hui, OR Zhao, Yuejin, 0A Zhou, Qun, OS Zou, Junqiu, 1G

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